



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Hidekazu MORIYAMA

Application No.: 10/827,426

Docket No.: 119295

Filed: April 20, 2004

For: CLEANING METHOD, STORAGE METHOD, PATTERN FORMATION
METHOD, DEVICE MANUFACTURING METHOD, ELECTRO-OPTICAL
DEVICE, AND ELECTRONIC APPARATUS

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Michael Britton
Registration No. 47,260

JAO:MQB/ale

Date: October 6, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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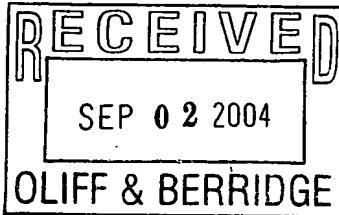
TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/827,426	04/20/2004	1746	1158	119295	11	14	6

25944
 OLIFF & BERRIDGE, PLC
 P.O. BOX 19928
 ALEXANDRIA, VA 22320



CONFIRMATION NO. 2552

UPDATED FILING RECEIPT



OC000000013674586

Date Mailed: 08/31/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Fujimi-machi
 Hidekazu Moriyama, Nagano-ken, JAPAN;

Assignment For Published Patent Application

SEIKO EPSON CORPORATION, Tokyo, JAPAN

Power of Attorney:

James Oliiff--27075	Robert A. Miller--32771
Kirk Hudson--27562	Mario Costantino--33565
William P. Berridge--30024	Michael Britton--47260
Thomas J. Pardini--30411	
Edward Walker--31450	

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2003-117164 04/22/2003

If Required, Foreign Filing License Granted: 06/29/2004

The number of your priority application, to be used for filing abroad under the Paris Convention is,
US10/827,426

Projected Publication Date: 12/09/2004

Non-Publication Request: No

Early Publication Request: No

Title

Cleaning method, storage method, pattern formation method, device manufacturing method, electro-optical device, and electronic apparatus

Preliminary Class

134

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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ATTORNEYS AT LAW

Supplemental Application Data Sheet



Application Information

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: CLEANING METHOD, STORAGE METHOD,
PATTERN FORMATION METHOD, DEVICE
MANUFACTURING METHOD, ELECTRO-
OPTICAL DEVICE, AND ELECTRONIC
APPARATUS
Attorney Docket Number:: 119295
Total Drawing Sheets:: 11
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Hidekazu
Family Name:: MORIYAMA
City of Residence:: Fujimi-machi
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-117164	04/22/2003	Yes
Assignee Information			
Assignee Name::	SEIKO EPSON CORPORATION		
Street of mailing address::	4-1, Nishishinjuku 2-chome, Shinjuku-ku		
City of mailing address::	Tokyo		
Country of mailing address::	Japan		
Postal or Zip Code of mailing address::	163-0811		